IAP20 ROS'S FOTATIO 03 JAN 2006

Application Data Sheet

Application Information

Application Type:: Utility

CD_ROM or CD-R?:: None

Title:: SILICON LAYER PRODUCTION METHOD AND

SOLAR CELL PRODUCTION METHOD

Attorney Docket Number:: 03500.109446.

Total Drawing Sheets:: 2

Small Entity?:: No

Applicant Information

Primary Citizenship Country:: Japan

Status:: Full Capacity

Given Name:: MASAKI

Family Name:: MIZUTANI

City of Residence:: Hikone-shi

State or Province of Residence:: Shiga-ken

Country of Residence:: Japan

Primary Citizenship Country:: Japan

Status:: Full Capacity

Given Name:: SHOJI

Family Name:: NISHIDA

City of Residence:: Hiratsuka-shi

State or Province of Residence:: Kanagawa-ken

Country of Residence:: Japan

Primary Citizenship Country:: Japan

Status:: Full Capacity

Given Name::

KATSUMI

Family Name::

NAKAGAWA

City of Residence::

Zama-shi

State or Province of Residence::

Kanagawa-ken

Country of Residence::

Japan

Correspondence Information

Correspondence Customer Number::

5514

Representative Information

Representative Customer Number::	05514
----------------------------------	-------

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National stage of	PCT/JP2005/009305	05/17/2005

Foreign Priority Information

Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2004-156968	05/27/2004	Yes

Assignee Information

Assignee name::

CANON KABUSHIKI KAISHA

Street of mailing address::

3-30-2, Shimomaruko, Ohta-ku,

City of mailing Address::

Tokyo

Country of mailing address::

Japan

Page # 2 Initial 12/30/2005